

IPW



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:  
Tzu-Chiang Sung et al.

Confirmation Number: 7583

Serial No.: 10/614,462

Group Art Unit: 2815  
Examiner: Landau, Matthew

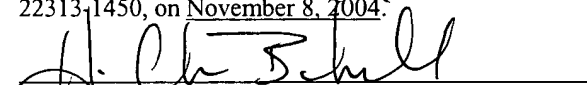
Filed: 07/07/2003

TKHR Docket No. 252011-1490  
Top-Team Ref. 0503-9856US

For: HIGH VOLTAGE METAL-OXIDE SEMICONDUCTOR DEVICE

**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 8, 2004.

  
Signature - Hui Chin Barnhill

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop -Amendment  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Office Action mailed September 15, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.